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## Probing molecular layers with low-energy electrons

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# Probing Molecular Layers with Low-Energy Electrons

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Cover illustration by Steffie Padmos, [www.steffiepadmos.com](http://www.steffiepadmos.com)

The cover depicts the experimental setup. In a Low-Energy Electron Microscope, a beam of electrons is emitted from an electron gun at the top, and is directed to the sample, i.e. molecular layers. After interaction with the sample, the reflected electrons are collected and guided to the detector at the bottom, where they form an image.

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# Table of Contents

<b>1 Introduction</b>	<b>1</b>
References	7
<b>2 Low Energy Electron Microscopy</b>	<b>15</b>
2.1 Introduction	16
2.2 Imaging in LEEM	18
2.3 Bright-field and dark-field imaging	22
2.4 Photoemission	22
2.5 Sample preparation	23
2.6 LEEM-IV spectroscopy	24
2.7 Angle-Resolved Reflected-Electron Spectroscopy (ARRES)	25
2.8 Electron Energy Loss Spectroscopy (EELS)	26
References	29
<b>3 Comparison of Pentacene Layer Growth on Graphite and hBN Flakes</b>	<b>35</b>
3.1 Introduction	36
3.2 Experimental Technique	37
3.3 Results	37
3.4 Discussion	43
3.5 Conclusions	46
References	48
Supporting Information	53
<b>4 Low-Energy Electron Irradiation Damage in Few-Monolayer Pentacene Films</b>	<b>57</b>
4.1 Introduction	58
4.2 Experimental Technique	59
4.3 Results	61
4.4 Discussion	65
4.5 Conclusions	68
References	70
Supporting Information	76

<b>5</b>	<b>Critical Role of Electronic States above the Vacuum Level in Photo-Electron and Secondary-Electron Emission in Few-Monolayer Pentacene Films</b>	<b>85</b>
5.1	Introduction	86
5.2	Experimental Technique	87
5.3	Results and Discussion	88
5.4	Conclusions	94
	References	95
	Supporting Information	100
<b>6</b>	<b>Band Structure of Few-Monolayer Pentacene Films Above the Vacuum Level</b>	<b>105</b>
6.1	Introduction	106
6.2	Experimental Technique and Results	106
6.3	Conclusions	117
	References	118
<b>7</b>	<b>Low Energy Electron Microscopy at Cryogenic Temperatures</b>	<b>121</b>
7.1	Introduction	122
7.2	Experimental Technique	123
7.3	Results and Discussion	128
7.4	Conclusions	133
	References	134
	<b>Summary</b>	<b>141</b>
	<b>Samenvatting</b>	<b>145</b>
	<b>Curriculum Vitae</b>	<b>151</b>
	<b>List of Publications</b>	<b>153</b>
	<b>Acknowledgments</b>	<b>155</b>





